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APPLICANTS

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** CONTINUING DATA *Yes TR*

This application is a DIV of 09/870,710 06/01/2001 PAT 6,720,661

** FOREIGN APPLICATIONS *Yes TR*

JAPAN 2000-166104 06/02/2000

JAPAN 2000-338737 11/07/2000

JAPAN 2001-125581 04/24/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met Verified and Acknowledged <i>[Signature]</i>	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>[Initials]</i>	JAPAN	17	23	1

ADDRESS

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TITLE

Semiconductor device, method of fabricating the same, stack-type semiconductor device, circuit board and electronic instrument

 All Fees 1.16 Fees (Filing)